

<b>Notice of References Cited</b>	Application/Control No. 10/693,673	Applicant(s)/Patent Under Reexamination BEDA ET AL.	
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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-2004/0093604	05-2004	Demsey et al.	719/310
	B	US-2003/0139848	07-2003	Cifra et al.	700/245
	C	US-6,314,470	11-2001	Ward et al.	719/328
	D	US-6,237,092	05-2001	Hayes, Jr., Kent Fillmore	713/100
	E	US-2004/0189645	09-2004	Beda et al.	345/473
	F	US-2002/0116417	08-2002	Weinberg et al.	707/517
	G	US-6,014,139	01-2000	Watson et al.	715/764
	H	US-2003/0126557	07-2003	Yardumian et al.	715/513
	I	US-2003/0110297	06-2003	Tabatabai et al.	709/246
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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